## Nanoconfined self-assembly on a grafted graphitic surface under electrochemical control

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**Figure S1:** a) First two voltammetric cycles of HOPG in 2 mM 3,5-TBD + 50 mM HCl. The first scan (blue trace) shows an irreversible reduction peak at E = -96 mV vs RHE. This peak is assigned to the reduction of the 3,5-TBD cations forming the corresponding radicals that immediately graft to the graphitic surface.<sup>1</sup> The second cycle (red trace) however, displays a featureless curve in the same potential regime. The disappearance of the well-defined reduction peak in the subsequent cycle is the result of the formation of a non-conductive grafted film at the interface that inhibits the electron transfer from the electrode surface to the 3,5-TBD cations; b) High resolution EC-STM images of HOPG surface covalently grafted by 3,5-TBD, substrate potential E = +147 mV vs RHE, U<sub>b</sub> = -179 mV, I<sub>t</sub> = 0.2 nA.

nm



Figure S2: Multiple CV cycling on 3,5-TBD grafted HOPG showing the consistency of the onset of both OER and HER.



**Figure S3:** CVs of HOPG electrode in contact with 50 mM HCl (black curve) and 0.1 mM DBV + 50 mM HCl (red curve). The presence of DBV molecules leads to the appearance of two reduction peaks at  $E_1 = -280$  mV and  $E_2 = -450$  mV vs RHE that are assigned to the stepwise reduction from dicationic DBV<sup>2+</sup> to the corresponding radical monocationic DBV<sup>++</sup> and uncharged DBV<sup>0</sup> species, respectively.



**Figure S4:** Structural correlation between the DBV<sup>\*+</sup> layer in the dimer phase and the underlying HOPG lattice; a) ECSTM image of the molecule covered HOPG: E = -340 mV, U<sub>b</sub> = +200 mV, I<sub>t</sub> = 0.1 nA; b) HOPG lattice underneath after the removal of the molecule: E = -340 mV vs RHE, U<sub>b</sub> = +10 mV, I<sub>t</sub> = 2.0 nA; c) superposition of panels a and b; d) tentative model of the dimer phase forming on hexagonal HOPG surface including the unit cell is proposed with the lattice constants of  $|\vec{a_2}| = 2.6 \pm 0.4 nm$  and  $|\vec{b_2}| = 1.6 \pm 0.4 nm$ , respectively, enclosing an angle of  $\beta = 60 \pm 4^0$ .



**Figure S5:** Structural correlation between the DBV<sup>0</sup> layer in the stacking phase and the underlying HOPG lattice, a) EC-STM image of the molecule covered HOPG: E = -510 mV vs RHE, U<sub>b</sub> = +350 mV, I<sub>t</sub> = 0.2 nA; b) EC-STM image of the HOPG lattice underneath after the removal of the molecule: E = -510 mV vs RHE, U<sub>b</sub> = +20 mV, I<sub>t</sub> = 1.8 nA; c) superposition of panels a and b; d) tentative model of the stacking phase forming on hexagonal HOPG surface. The unit cell of the DBV<sup>0</sup> adlayer is proposed with the lattice constants of  $|\vec{a_2}| = 0.6 \pm 0.4 \text{ nm}$  and  $|\vec{b_2}| = 2.5 \pm 0.4 \text{ nm}$ , respectively, enclosing an angle of  $\gamma = 59 \pm 4^0$ 



Substrate potential increasing

Figure S6: Dynamics of phase transition from the stacking phase to the dimer phase within nanocorrals:  $U_b$  = +120mV,  $I_t$  = 0.2 nA



## Substrate potential decreasing

**Figure S7:** EC-STM images of (a) stacking phase, (b) dimer phase and (c) gas phase forming on bare HOPG at different electrode potentials indicated in the figures:  $U_b = +150 \text{ mV}$ ,  $I_t = 0.1 \text{ nA}$ ; c) dynamics of phase transition; the gas phase - the dimer phase - the stacking phase:  $U_b = +175 \text{ mV}$ ,  $I_t = 0.1 \text{ nA}$ .

## References

1. J. Greenwood, T. H. Phan, Y. Fujita, Z. Li, O. Ivasenko, W. Vanderlinden, H. Van Gorp, W. Frederickx, G. Lu, K. Tahara, Y. Tobe, H. Uji-i, S. F. L. Mertens and S. De Feyter, *ACS Nano*, 2015, **9**, 5520-5535.